



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 9191**
Makoto AKIZUKI et al. : **Docket No. 2001-1897**
Serial No. 10/025,899 : **Group Art Unit 1762**
Filed December 26, 2001 : **Examiner B. Pinalto**

METHOD FOR FORMING GAS CLUSTER AND
METHOD FOR FORMING THIN FILM

PATENT OFFICE FEE TRANSMITTAL FORM

Assistant Commissioner for Patents,
Washington, DC 20231

Sir:

Attached hereto is a check in the amount of \$930.00 to cover Patent Office fees relating to filing the following attached papers:

Petition for Extension of Time \$930.00

Other: \$

A duplicate copy of this paper is being submitted for use in the Accounting Division, Office of Finance.

The Commissioner is authorized to charge any deficiency or to credit any overpayment associated with this communication to Deposit Account No. 23-0975, with the EXCEPTION of deficiencies in fees for multiple dependent claims in new applications.

Respectfully submitted,

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February 7, 2003

[Check No. 5,111,111]

2001-1897